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First Named Inventor/Applicant Name:	Takashi Ozaki		
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File Listing:					
Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)

Number	Document Description	File Name	/Message Digest	Part /.zip	(if appl.)
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	Information Disclosure Statement (IDS) Filed		6	6	
Warnings:					
Information:					
2	Faraign Reference	JP-3242244.pdf	381562	no	7
2	Foreign Reference		oeb7a698923ao45816405ac68adoe970 1593857o	110	
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3	Foreign Reference	JP-9-134913.pdf	343031	no	7
	Toroign Fictorial		c917023acc3ac012b283c09d569c6460 492be450	110	
Warnings:					
Information:					
4	NPL Documents	ROC-Office-Action.pdf	710642	no	16
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National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.